

U.S. UTILITY Patent Application

O.I.P.E.

PATENT DATE

1767 *TM*

APPLICATION NO.

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CONT/PRIOR

CLASS

257

SUBCLASS

350

ART UNIT

2813

EXAMINER

Colin Lee

APPLICANTS
TITLE

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Si-MOS high-frequency semiconductor device and the manufacturing method of the same

PTO-2040
12/89

<p>(Primary Examiner) <i>17</i> (Date) <i>8/</i></p>		<p>ISSUE CATCH NUMBER</p>
<p>(Legal Instruments Examiner) (Date)</p>		

☐ The terminal _____ months of this patent have been determined.

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